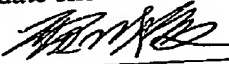


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Certificate of Facsimile Transmission

I hereby certify that the attached Transmittal (2 pages), Response to the Final Office Action dated September 2, 2005 (9 pages) are submitted to the U.S. Patent and Trademark Office via facsimile number 571-273-8300 on the date shown below. (Total 11 pages).


Li Mei Vermilya

Date: November 29, 2005

RESPONSE UNDER 37 CFR 1.116
EXPEDITED PROCEDURE
EXAMINING GROUP 2826PATENT APPLICATION
Docket No.: 8750-064
Client Ref. No.: SPX200212-0002US

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of: Ho-Ouk LEE and Hyo-Dong BAN

Serial No.: 10/803,064

Examiner: Quach, Tuan N.

Filed: March 16, 2004

Group Art Unit: 2826

Confirmation No.: 5182

For: SEMICONDUCTOR DEVICES HAVING DUAL CAPPING LAYER
PATTERNS AND METHODS OF MANUFACTURING THE SAMEMail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Responsive to the Final Office Action dated September 2, 2005, enclosed is an amendment in the above-identified application.

The fee has been calculated as shown below.

CLAIMS AS AMENDED					
For:	Number After Amendment	Previous Number	Extra	Rate	Additional Fee
Total Claims	12	12	0	x \$50 =	\$0
Independent Claims	2	2	0	x \$200 =	\$0
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0

*greater of twenty (20) or number for which fee has been paid


**greater of three (3) or number for which fee has been paid

☒ Any deficiency or overpayment should be charged or credited to deposit account number 13-1703.

Customer No. 20575

Respectfully submitted,

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SEMICONDUCTOR DEVICES HAVING DUAL CAPPING LAYER
PATTERNS AND METHODS OF MANUFACTURING THE SAME

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE AFTER FINAL REJECTION UNDER 37 CFR 1.116

This paper is responsive to the Final Office Action (Paper No. 0905) that was mailed on 2 September 2005.

A Listing of Claims that reflects the current status of the claims begins on page 2 of this paper.

Remarks/Arguments begin on page 6 of this paper.

Docket No. 8750-064

Page 1 of 9

Application No. 10/803,064